

ULTRA-CLEAN IONIZATION SOLUTIONS





2.31 lb (1.04 kg)



1.4 lb (0.64 kg)





0.24 lb (0.11 kg)



0.3 lb (0.136 kg)

Micro Series	Model 4210 (u)(n)	Model 4214 (un)	Model 4630 Quadbar	Model 4635 Quadbar	Model fusION In-line
Feature	Model 4210: CDA or N₂ high output tungsten emitters for general use in-line applications Model 4210u: CDA with Single-crystal Silicon emitters for ISO 14644-1 Class 3 Model 4210un: N₂ with Single-crystal Silicon emitters for ultra-clean applications	Self-balanced, no calibration required; unlike other N ₂ ionizers which depend on the trace gases in the nitrogen stream to produce ionization, it is designed to ionize N ₂ (99.999%) gas flow in ultra-clean semiconductor and other high purity processes	Unique quadrupole ensure effective ionization as close as 3" from the product	Quadrupole configuration with unique cross- channel air cartridge around emitter points for independent air delivery in tight space Standard Cartridge: Fits around emitter points to provide CDA or N ₂ Jet Cartridge: High-velocity jet for air centered between all 4 emitter points to greatly reduced discharge times	Fast decay times through output tubes; tubes may be split into multiple tubes to service multiple locations Optimal Performance: Use nitrogen kit for pure N₂ or 1-2% CDA mixture application
Discharge	4210: 10 sec 4210u: 5 sec 4210un: 10 sec Measured through 6" long, 1/4" ID Teflon tube held 6" from the CPM, airflow rate of 2 scfm	Without manifold: <10 sec @ 6"(15.2 cm) With manifold: <100 sec @ 19.6"(49.8 cm)	<30 sec @ 12" (30.5 cm) Directly under emitter points (80-100 fpm airflow)	Standard Cartridge: <15 sec @ 12" (30.5 cm) Jet Cartridge: <6 sec @ 12" (30.5 cm) Directly under emitter points (0.53 cfm purging gas airflow)	<5 sec @ 6" (15 cm) (10 psi gas pressure)
Balance	<±25V @ 6" (15.2 cm) (specified flow & pressure)	±25V @ 6" (15.2 cm)	Intrinsically balanced ±50V @ 6" & 12" Directly under emitter points with airflow	Intrinsically balanced ±50V @ 6" & 12" Directly under emitter points with airflow	<±50V
Ion Emission	IsoStat Technology	High Frequency AC Technology	Steady-state DC Technology	Steady-state DC Technology	Steady-state DC Technology
Cleanroom Class	4210: ISO 14644-1 Class 5 4210u: ISO 14644-1 Class 3 4210un: ISO 14644-1 Class 3	ISO 14644-1 Class 1 (0.1 μm particles) Extended ISO Class 1 (0.01 μm particles)	ISO 14644-1 Class 1 (24 VDC) ISO 14644-1 Class 2 (24 VAC & Ctrl)	ISO 14644-1 Class 1 (24 VDC) ISO 14644-1 Class 2 (24 VAC & Ctrl)	ISO 14644-1 Class 4
Airflow	CDA or N₂ (min 1.5 cfm @ 10-50 psi)	N₂ 3.53 cfm @ 30 psi (100 lpm @ 207 kPa), max	Laminar Flow (80-100 fpm)	CDA or N₂ 0-25 lpm @ 0-7 psi	CDA or N_2 (0.8 scfm @ 5 psi to 3.6 scfm @ 50 psi)
Dimension/ Weight	2.38"D x 4.75"L x 3.13"W (6.06 x 12.0 x 7.95 cm)	6.01″L x 2.85″W x 1.26″H (15.2 x 7.26 x 3.20 cm)	1.38"H x 1.28"W x 4.50"L (3.56 x 3.30 x 11.4 cm) with flange	1.42"H x 1.32"W x 4.50"L (3.61 x 3.35 x 11.4 cm) with flange	2.52"H x 1.28"W x 4.50"L (6.40 x 3.25 x 11.4 cm) includes air connectors

0.22 lb (0.10 kg)